2-24-06; 1:55PM;SSMP FAX

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# SCULLY, SCOTT, MURPHY



Examiner: C.Q. Nguyen To:

Art Unit: 2811

Leslie S. Szivos

571-273-8300 Fax

Pages:

16 pages including fax cover sheet

**Phone:** 

Re:

Date:

2/24/2006

U.S. Patent Appln. No. 10/700,085

CC:

Docket: YOR920030586US1 (17201)

Confirmation No. 2805

Filed: November 3, 2003

### RESPONSE TO OFFICE ACTION

Please see the following documents:

- Amendment Transmittal (in duplicate)
- Authorization to charge IBM deposit account
- Response under 37 C.F.R. § 1.111 (12 pages) 3.
- Certificate of transmission by facsimile dated February 24, 2006

If you have any questions concerning this facsimile please contact Vivian Henriquez at 516-742-4343. Thank you.

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## RECEIVED CENTRAL FAX CENTER 167424366

Docket No. CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8) Applicant(s): Tze-chiang Chen et al. YOR920030586US1 (17201) Application No. **Group Art Unit** Filing Date **Examiner** 10/700,085 2811 November 3, 2003 C. Q. Nguyen Invention: METHOD FOR FABRICATING SiGe-ON-INSULATOR (SGOI) AND Ge-ON-INSULATOR (GOI) SUBSTRATES Response under 37 C.F.R. § 1.111 I hereby certify that this (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 571-273-8300 February 24, 2006 on (Date) Leslie S. Sziyos, Ph.D. (Typed or Printed Name of Ferson (Signature) Note: Each paper must have its own certificate of mailing.

cc:

FEB 2 4 2006 :5167424366 AMENDMENT TRANSMITTAL LETTER (Large Entity) Docket No. Applicant(s): Tze-chiang Chen et al. YOR920030586US1 (17201) Application No. Customer No. Group Art Unit Confirmation No. Filing Date Examiner 10/700,085 23389 2811 2805 November 3, 2003 C. Q. Nguyen METHOD FOR FABRICATING SIGE-ON-INSULATOR (SGOI) Invention: AND Ge-ON-INSULATOR (GOI) SUBSTRATES **COMMISSIONER FOR PATENTS:** Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below. **CLAIMS AS AMENDED CLAIMS REMAINING** HIGHEST # NUMBER EXTRA **ADDITIONAL** RATE AFTER AMENDMENT PREV. PAID FOR CLAIMS PRESENT FEE **TOTAL CLAIMS** 36 68 0 х \$50.00 \$0.00 INDEP. CLAIMS 3 0 \$200.00 \$0.00 X \$0.00 Multiple Dependent Claims (check if applicable) \$0.00 TOTAL ADDITIONAL FEE FOR THIS AMENDMENT No additional fee is required for amendment. ☐ Please charge Deposit Account No. in the amount of A check in the amount of to cover the filing fee is enclosed. The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM Any additional filing fees required under 37 C.F.R. 1.16. Any patent application processing fees under 37 CFR 1.17. ☐ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. Dated: February 24, 2006 Signature Leslie S. Szivos, Ph.D. Registration No. 39,394 I hereby certify that this correspondence is being deposited with SCULLY, SCOTT, MURPHY & PRESSER, P.C. the United States Postal Service with sufficient postage as first 400 Garden City Plaza - Suite 300 class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37-CFR 1.8(a)] on Garden City, New York 11530 (Date)

Signature of Person Mailing Correspondence

Typed or Printed Name of Person Mailing Correspondence

:5167424366

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FEB 2 4 2006

AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Tze-chiang Chen et al.						Docket No. YOR920030586US1 (17201)		
Application No. 10/700,085	Filing Date November 3, 2003	Examiner C. Q. Nguyen		Customer N 23389	lo.	Group Art Un 2811	t Confirmation No. 2805	
Invention: METHOD FOR FABRICATING SiGe-ON-INSULATOR (SGOI) AND Ge-ON-INSULATOR (GOI) SUBSTRATES								
COMMISSIONER FOR PATENTS:								
Transmitted herewith is an amendment in the above-identified application.  The fee has been calculated and is transmitted as shown below.								
CLAIMS AS AMENDED								
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST #		ER EXTRA		RATE	ADDITIONAL FEE	
TOTAL CLAIMS	36 -	68 =		0	х	\$50.00	\$0.00	
INDEP, CLAIMS	3 -	6 =		0	x	\$200.00	\$0.00	
Multiple Dependent Claims (check if applicable)							\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT							\$0.00	
□ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. □ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM □ Any additional filing fees required under 37 C.F.R. 1.16. □ Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. □ WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. □ Dated: February 24, 2006 □ Signature □ Leslie S. Szivos, Ph.D. Registration No. 39,394 SCUILLY, SCOTT, MURPHY & PRESSER, P.C. 400 Garden City Plaza - Suite 300 Garden City New York 11530 □ I hereby certify that this correspondence is being deposited with the tulted States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents." P.O. Box 1438, Alexandria, VA 22313-1450 (37 CFR 1.8(a)) on								
Garden City, New York 11530    P.O. Box 1459 Alexandra, VA 22513-430 [57 OF N 1.5(a)] On Signature of Person Mailing Correspondence    Column								

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#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tze-chiang Chen, et al.

Examiner: C.Q. Nguyen

Dated: February 24, 2006

Serial No:

10/700,085

Art Unit: 2811

Filed:

November 3, 2003

Docket: YOR920030586US1 (17201)

For: METHOD FOR FABRICATING

SiGe-ON-INSULATOR (SGOI) AND

Ge-ON-INSULATOR (GOI) SUBSTRATES

Confirmation No. 2805

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

### RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action dated November 30, 2005, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

### **CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: February 24, 2006

Leslie S. Szivos, Ph.D.